



JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Naoyuki KURIHARA

Group Art Unit: 2618

Appln. No. : 10/620,353

Examiner: Simon Nguyen

Filed : July 17, 2003

Confirmation No.:8918

For : DELAY PROFILE MAKING METHOD AND DELAY PROFILE MAKING APPARATUS

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Issue Fee
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Notice of Allowability, mailed by the U.S. Patent and Trademark Office on May 26, 2006 and to the Statement of Reasons for Allowance attached thereto, Applicant wishes to clarify the record with respect to the basis for the patentability of claims in the present application. While Applicant does not disagree with the Examiner's indication that certain identified features are not disclosed by the references, Applicant submits that each of the claims in the present application recite a particular combination of features, and that the basis for patentability of each of these claims is based on the totality of the particular features recited therein.

P23984.A04

Should there be any questions, the Examiner is requested to contact the undersigned at the below-listed telephone number.

Respectfully submitted,
Naoyuki KURIHARA



Bruce H. Bernstein
Reg. No. 29,027

Steven Wegman
Reg. No. 31,438

June 23, 2006
GREENBLUM & BERNSTEIN, P.L.C.
1950 Roland Clarke Place
Reston, VA 20191
(703) 716-1191

P23984 00025063.DOC}